



Application No. 10/697,053
Attorney Docket No. SEC.1049
Amendment Filed September 1, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of : Allowed: June 2, 2005
Jin-Sung Kim et al. : Group Art Unit: 2823
Application No.: 10/697,053 : Examiner: Pham, Thanh V.
Filed: October 31, 2003 :

METHOD OF FORMING A POROUS MATERIAL LAYER IN A SEMICONDUCTOR
DEVICE

AMENDMENT AFTER ALLOWANCE

U.S. Patent and Trademark Office
Customer Service Window, Mail Stop Issue Fee
Randolph Building
401 Dulany Street
Alexandria VA 22314

Sir:

Subsequent to the issuance of a Notice of Allowance dated June 2, 2005, and prior to the payment of the issue fee, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.